



Application of: Trung T. Doan

Serial No.: 09/652,713

Filed: August 31, 2000

For: CHEMICAL DISPENSING SYSTEM  
FOR SEMICONDUCTOR WAFER  
PROCESSING

§ Group Art Unit: 1763  
§  
§ Examiner: Sylvia R. MacArthur  
§  
§ Atty. Docket: 93-0421.04  
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Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below:

7-19-01  
Date

Trish Homan-Quider  
Signature

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136(a)

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Applicant hereby petitions to extend the period for response to the Office Action mailed January 19, 2001 for three (3) months, from April 19, 2001 to July 19, 2001.

Accordingly, the requisite fee is \$ 890. The Commissioner is requested to charge this fee, and any additional fee which may be required to Micron Technology, Inc. Deposit Account 13-3092, Order No. 93-0421.04. A duplicate copy of this petition is enclosed.

Respectfully submitted,

Date: 7/19/01

Charles B. Brantley

Charles B. Brantley, II, Reg. No. 38,086  
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